

## ERRATUM

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### Erratum: "A discussion of the chemical mixing process for *in situ* preparation of silicon carbide whiskers in silicon nitride powder" [*J. Mater. Res.* 3, 538 (1988)]

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The address given for Shigehiko Yamada in the May/June issue of *Journal of Materials Research* is incorrect. The author belongs to the Industrial Research Institute but is currently carrying out research at the

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